

<b>Notice of References Cited</b>	Application/Control No. 10/665,849	Applicant(s)/Patent Under Reexamination KRIS ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,798,903 b2	09-2004	Takaoka, Naoki	382/167
*	B	US-6,895,112 b2	05-2005	Chen et al.	382/167
*	C	US-5,432,863	07-1995	Benati et al.	382/167
*	D	US-6,868,178 b1	03-2005	Frei et al.	382/162
*	E	US-6,665,434 b1	12-2003	Yamaguchi, Hiroshi	382/162
*	F	US-6,407,777 b1	06-2002	DeLuca, Michael Joseph	348/576
*	G	US-5,990,973	11-1999	Sakamoto, Shizuo	348/576
*	H	US-6,728,401 b1	04-2004	Hardeberg, Jon Y.	382/167
*	I	US-6,204,858 b1	03-2001	Gupta, Naresh C.	345/600
*	J	US-6,631,208 b1	10-2003	Kinjo et al.	382/167
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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